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Man San San			ATTORNEY DOCKET NO.	CONFIRMATION NO.		
APPLICATION NO. 09/681,643	FILING DATE	FIRST NAMED INVENTOR	JP920000112US1	8744		
	05/15/2001	Takatoshi Tsujimura	JP920000112081			
IBM CORPC	7590 02/04/2003 DRATION, T.J. WATSO	_{02/04/2003} TION, T.J. WATSON RESEARCH CENTER		EXAMINER COLEMAN, WILLIAM D		
P.O. BOX 218 YORKTOWN	HEIGHTS, NY 10598		ART UNIT	PAPER NUMBER		
			DATE MAILED: 02/04/2003	3		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No. Applicant(s)		b	1			
Office Action Summary		09/681,643	•	TSUJIMURA ET A	AL.			
		Examiner		Art Unit				
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	- The MAILING DATE of this communication app	nears on the cove.	r sheet with the	e correspondence a	aaress			
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A SHC THE M - Extens after S - If the - If NO - Failure - Any re earned	DRTENED STATUTORY PERIOD FOR REPLY MAILING DATE OF THIS COMMUNICATION. Insions of time may be available under the provisions of 37 CFR 1.13 SIX (6) MONTHS from the mailing date of this communication. Period for reply specified above is less than thirty (30) days, a reply period for reply is specified above, the maximum statutory period we re to reply within the set or extended period for reply will, by statute, reply received by the Office later than three months after the mailing and patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, how bly within the statutory min will apply and will expire	wever, may a reply be ninimum of thirty (30) d e SIX (6) MONTHS fro	e timely filed days will be considered time from the mailing date of this DNED (35 U.S.C. § 133).	nely . communication.			
Status	Responsive to communication(s) filed on <u>04 L</u>	December 2002						
1)	The court of the	his action is non-	-final.					
2a)⊡	This action is the terminal	for allowance except for formal matters, prosecution as to the merits is						
3) 🗌 Dispositi	closed in accordance with the practice under ion of Claims	LX parto quay.	e, 1935 C.D. 1	1, 453 O.G. 213.				
4)[3]	Claim(s) 1-16 is/are pending in the application	on.						
الحدار،	4a) Of the above claim(s) 10-16 is/are withdraw	awn from conside	eration.					
	Claim(s) is/are allowed.							
1								
7)	Claim(s) is/are objected to.							
8)□	are subject to restriction and/	or election requi	irement.					
Applicat	tion Papers							
	The enecification is objected to by the Examin	ner.		ما ما المعالم الما المعالم الما المعالم الما الما				
10)	accionation accionation is/are: a) acci	cepted or b) \ obje	ected to by the	Examiner.	(2)			
1		the drawing(s) be	neig in abeyance	,6, 000 0, 0, 1, 1, 1, 1	na). miner			
11)	The proposed drawing correction filed on	is: a)∐ appro	roved b) L disa	approved by the Exa	annici.			
	If approved, corrected drawings are required in a	reply to this Office	e action.					
12) The oath or declaration is objected to by the Examiner.								
	1 25 U.S.C. 88 119 and 120			40/ 5.45				
12/	Acknowledgment is made of a claim for foreign	ign priority unde	ır 35 U.S.C. § 1	119(a)-(d) or (f).				
13)	a) ☐ All b) ☐ Some * c) ☐ None of:							
1	Contified copies of the priority documents have been received.							
	a Constituted copies of the priority documents have been received in Application No.							
3. Copies of the certified copies of the priority documents have been received in this National Stage								
The control of the co								
Asknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application)								
a) The translation of the foreign language provisional application has been received. 15) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.								
Attachm								
1) [] N	Notice of References Cited (PTO-892) Notice of Draftsperson's Patent Drawing Review (PTO-948) Information Disclosure Statement(s) (PTO-1449) Paper Not	8) 5	4) Interview Su 5) Notice of Inf 6) Other:	Summary (PTO-413) Pap nformal Patent Applicatio	ion (PTO-152)			

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DETAILED ACTION

Election/Restrictions

Applicant's election with traverse of claims 1-10 in Paper No. 8 is acknowledged. The 1. traversal is on the ground(s) that claims 10-16 are not classifiable in class 118. This is not found persuasive because as Applicant has stated to be classified in this class the work treated must not be a part of the coating machine itself but must be an article separate and distinct therefrom. It is well known that semiconductor devices fabricated in process chambers are not part of the coating machine and therefore the restriction requirement was proper.

The requirement is still deemed proper and is therefore made FINAL. 2.

Response to Arguments

- Applicant's arguments filed December 4, 2002 have been fully considered but they are 3. not persuasive.
- Applicants contend that the current patent application filed May 15, 2001 is entitled to 4. the benefits of having the present application examined under the AIPA changes to 35 U.S.C. 102 § 102(e).
- In response to Applicants contention that the current Application was examined under 35 5. U.S.C. 102 § 102(e), Applicants are mistaken. The present Application was rejected under 35 U.S.C. 103(a), see MPEP 706.02(j).
- In response to applicant's argument that there is no suggestion to combine the references, 6. the examiner recognizes that obviousness can only be established by combining or modifying the teachings of the prior art to produce the claimed invention where there is some teaching,

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suggestion, or motivation to do so found either in the references themselves or in the knowledge generally available to one of ordinary skill in the art. See *In re Fine*, 837 F.2d 1071, 5 USPQ2d 1596 (Fed. Cir. 1988)and *In re Jones*, 958 F.2d 347, 21 USPQ2d 1941 (Fed. Cir. 1992). In this case, the chamber requires cleaning after the formation of the oxide layer, it is obvious that an oxide is formed on the chamber wall.

Claim Rejections - 35 USC § 103

- 7. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 8. Claims 1-10 are rejected under 35 U.S.C. 103(a) as being unpatentable over Ohnuma et al., U.S. Patent 6,072,193 in view of Gardner et al., U.S. Patent 6,066,519.
- 9. Pertaining to claims 1 and 2, Ohnuma discloses a semiconductor process substantially as claimed. See **FIGS. 1A-2D**, where Ohnuma teaches a manufacturing method of an active matrix device (column 17, line 62) including a top gate type TFT, which comprises a process of forming the top gate type TFT, wherein the process of forming the top gate type TFT includes the steps of:

arranging a substrate **101** having source **125** and drain electrodes **126** formed therein in the processing chamber; doping the source and drain electrodes with P (phosphorous), (column 3, lines 51-54); and forming an a-Si layer **103** and a gate insulating film **104** in the processing chamber. However, Ohnuma fails to disclose forming an oxide film on an inner wall of a CVD processing chamber. Gardner teaches forming an oxide on an inner wall of a CVD processing

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chamber (column 6, lines 8-14). In view of <u>Gardner</u>, it would have been obvious to one of ordinary skill in the art because when forming a gate dielectric residual oxide forms on the chamber walls (column 6, lines 10-12).

- 10. Pertaining to claim 2, Ohnuma fails to disclose removing the oxide film form the inner wall after the step of forming the a-Si layer and the gate insulating layer. Gardner teaches the step of removing oxide between runs. In view Gardner, it would have been obvious to one of ordinary skill in the are to remove oxide from the chamber walls after the step of forming the a-Si layer and the gate insulating film because the a silicon gate dielectric layer may be formed in a highly controlled manner (column 6, lines 21-23).
- 11. Pertaining to claim 3, Ohnuma teaches a manufacturing method of an active matrix device according to claim 1,

wherein the oxide film contains SiOx.

- 12. Pertaining to claim 4, Ohnuma teaches a manufacturing method of an active matrix device according to claim 1, wherein the active matrix device is a liquid crystal display (column 17, line 62).
- 13. Pertaining to claim 5, Ohnuma teaches a manufacturing method of an active matrix device according to claim 1, wherein the active matrix device is an electroluminescence display (column 17, line 62).
- 14. Pertaining to claim 6, Ohnuma teaches a manufacturing method of an active matrix device according to claim 2, wherein the oxide film contains SiOx.
- 15. Pertaining to claim 7, Ohnuma teaches a manufacturing method of an active matrix device according to claim 2, wherein the active matrix device is a liquid crystal display.

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Pertaining to claim 8, Ohnuma teaches a manufacturing method of an active matrix 16. device according to claim 3, wherein the active matrix device is a liquid crystal display.

- Pertaining to claim 9, Ohnuma teaches a manufacturing method of an active matrix 17. device according to claim 2, wherein the active matrix device is an electroluminescence display.
- Pertaining to claim 10, Ohnuma teaches a manufacturing method of an active matrix 18. device according to claim 3, wherein the active matrix device is an electroluminescence display.

Conclusion

- THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time 19. policy as set forth in 37 CFR 1.136(a).
- A shortened statutory period for reply to this final action is set to expire THREE 20. MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.
 - Any inquiry concerning this communication or earlier communications from the 21. examiner should be directed to W. David Coleman whose telephone number is 703-305-0004. The examiner can normally be reached on 9:00 AM-5:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Olik Chaudhuri can be reached on 703-306-2794. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7722 for regular communications and 703-308-7721 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

W. David Coleman

Examiner Art Unit 2823

WDC January 31, 2003